



ELECTRONIC COPY

LG793647029
Report verification at igi.org



April 24, 2026

IGI Report Number **LG793647029**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PEAR BRILLIANT**

Measurements **8.59 X 5.63 X 3.63 MM**

GRADING RESULTS

Carat Weight **1.05 CARAT**

Color Grade **D**

Clarity Grade **VS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

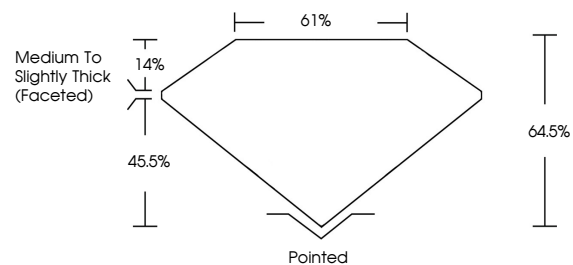
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG793647029**

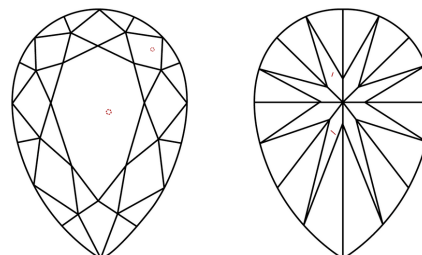
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

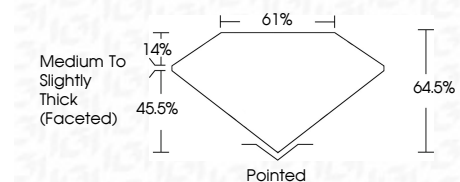
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



April 24, 2026
IGI Report No. LG793647029
PEAR BRILLIANT
8.59 X 5.63 X 3.63 MM
Carat Weight
Color Grade **D**
Clarity Grade **VS 2**
Depth **45.5%**
Table **14%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG793647029**

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